



ASME/C.047AUS

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hannu Huotari
Appl. No. : 10/601,037
Filed : June 19, 2003
For : METHOD TO FABRICATE
DUAL METAL CMOS DEVICES
Examiner : Christy L. Novacek
Group Art Unit : 2822

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

May 15, 2006

(Date)

Andrew N. Merickel, Reg. No. 53,317

AMENDMENT AND REQUEST FOR CONTINUED EXAMINATION

Mail Stop AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted with a Request for Continued Examination and is responsive to the Final Office Action mailed on February 13, 2006. As the present amendments are believed to place the application in condition for allowance and do not require extensive consideration, their entry is respectfully requested.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.